IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)

Richard SPITZ et al.

Serial No.

09/720.720

Filed

February 2**8**, 2001

For

[10191/1614] FCEIVEL K OFFICE JUL 3 / 200: METHOD FOR ELIMINATING DEFECTS IN SILICON ELEMENTS

THROUGH SELECTIVE ETCHING

Examiner

Binh TRAN

Group Art Unit:

1765

Confirmation No.:

3872

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

NOTICE OF APPEAL

SIR:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision of the Examiner made in the Final Office Action dated March 17, 2003 finally rejecting 31, 33 and 35. Claims 16-25 and 27-30 are allowed. Claims 32 and 34 are objected to.

The Commissioner is hereby authorized to charge payment of the 37 C.F.R. 1.191 Notice of Appeal fee of \$320.00 to the deposit account of Kenyon & Kenyon, Deposit Account No. 11-0600. Any additional fees deemed necessary should also be charged to Deposit Account No. 11-0600. Two additional copies of this Notice are enclosed for that purpose.

Applicants request a further one month extension of time to respond to the Final Office Action mailed March 17, 2003. This further one month extension of time resets the response date to August 18, 2003 (August 17, 2003 is a Sunday). The extension fee of \$300.00 should be charged to the deposit account of Kenyon & Kenyon, Deposit Account No. 11-0600.

Dated: 7/25/03

35/16/35/10

I harshy certify that this correspondence is being deposited with United States Postal Service with sufficient postage as first class 26646 in an envelope addressed to: 1 -1 Styn

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